

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : TBD
Applicant : Yasuyuki Naito et al.
Filed : Herewith
Title : "ELECTROMECHANICAL FILTER"

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Docket No. : 40337

INFORMATION DISCLOSURE STATEMENT

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Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (ISR, copy enclosed) and in the enclosed copy of Patent Office Form 1449. Copies of the publications cited in the International Search Report are not enclosed as they were previously forwarded by the International Bureau, however, a copy of the publication cited in the specification is enclosed.

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Respectfully submitted,

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INFORMATION DISCLOSURE CITATION BY APPLICANT <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: Yasuyuki Naito et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	1-114111	05/1989	JAPAN			Cited on ISR
	M	2-52514	02/1990	JAPAN			Cited on ISR
	N	2003-309449	10/2003	JAPAN			Cited on ISR
	P						
	Q						

OTHER REFERENCES *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	R	Schloemann et al., "Epitaxial Fe films on GaAs for hybrid semiconductor-magnetic memories", 04/1988, pages 3140-3142 (Cited in Specification-English Text)
	S	
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